

O I P E  
INFORMATION DISCLOSURE CITATION  
(Use several sheets if necessary)

JAN 28 2005

Docket Number (Optional)  
NEC NE03P181

Application Number  
10/748,821

Applicant(s)

OHTO et al.

Filing Date

December 30, 2003

Group Art Unit

2812

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JS		6,162,743	12.19.00	CHU et al.	438	781	

U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JS		2001/0004550	6.21.01	PASSEMARD	438	618	

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

*JS*

DATE CONSIDERED

3/1/06

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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## FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	2001-127159	11.05.2001	JAPAN (w/Abstract)	H01L	21/768		✓
	2002-083870	22.03.2002	JAPAN (w/Abstract)	H01L	21/768		✓
	2002-275631	25.09.2002	JAPAN (w/Abstract)	C23C	16/42		✓
	WO 99/41423	19.08.1999	WIPO	C23C	A2		✓
	WO 00/19498	06.04.2000	WIPO	H01L	21/027		✓

**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, Etc.)*

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